

EAST Search History

| Ref # | Hits | Search Query | DBs | Default Operator | Plurals | Time Stamp |
|-------|---------|--|-----------------|------------------|---------|------------------|
| L1 | 0 | (SiGeC or (silicon with germanium with carbon)) with epitaxial\$2 with (CVD or chemical vapor deposition) with ("N.sub.2") | US-PGPUB; USPAT | OR | OFF | 2007/12/05 16:08 |
| L2 | 81 | (SiGeC or (silicon with germanium with carbon)) with epitaxial\$2 with (CVD or chemical vapor deposition") with ("N.sub.2")") | US-PGPUB; USPAT | OR | OFF | 2007/12/05 16:24 |
| L3 | 1637842 | @ad>"20021003" or @rlad>"20021003" | US-PGPUB; USPAT | OR | OFF | 2007/12/05 16:11 |
| L4 | 16 | 2 not 3 | US-PGPUB; USPAT | OR | OFF | 2007/12/05 16:11 |
| L5 | 0 | (SiGeC or (silicon with germanium with carbon)) with epitaxial\$2 with (CVD or "chemical vapor deposition") with ("N.sub.2" or nitrogen) | US-PGPUB; USPAT | OR | OFF | 2007/12/05 16:15 |
| L6 | 0 | (SiGeC or (silicon with germanium with carbon)) with epitaxial\$2 with (CVD or "chemical vapor deposition") with ("N.sub.2" or nitrogen) | US-PGPUB; USPAT | OR | OFF | 2007/12/05 16:15 |
| L7 | 0 | (SiGeC or (silicon with germanium with carbon)) with epitaxial\$2 with (CVD or "chemical vapor deposition") with (nitrogen) | US-PGPUB; USPAT | OR | OFF | 2007/12/05 16:19 |
| L8 | 0 | (SiGeC or (silicon with germanium with carbon)) with epitaxial\$2 with (CVD or "chemical vapor deposition") same (nitrogen) | US-PGPUB; USPAT | OR | OFF | 2007/12/05 16:20 |
| L9 | 0 | (SiGeC or (silicon with germanium with carbon)) with epitaxial\$2 with ((CVD or "chemical vapor deposition") same (nitrogen)) | US-PGPUB; USPAT | OR | OFF | 2007/12/05 16:20 |
| L10 | 0 | (SiGeC or (silicon with germanium with carbon)) with epitaxial\$2 with ((CVD or "chemical vapor deposition") same ("N.sub.2" or nitrogen)) | US-PGPUB; USPAT | OR | OFF | 2007/12/05 16:21 |
| L11 | 8 | (SiGeC or (silicon with germanium with carbon)) with CVD with ("N.sub.2" or nitrogen) | US-PGPUB; USPAT | OR | OFF | 2007/12/05 16:21 |
| L12 | 4 | 11 not 3 | US-PGPUB; USPAT | OR | OFF | 2007/12/05 16:21 |
| L13 | 8 | (SiGeC or (silicon with germanium with carbon)) with (CVD or "chemical vapor deposition") with ("N.sub.2" or nitrogen) | US-PGPUB; USPAT | OR | OFF | 2007/12/05 16:28 |

EAST Search History

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|-----|---|----------|--------------------|----|-----|------------------|
| L14 | 4 | 13 not 3 | US-PGPUB; USPAT | OR | OFF | 2007/12/05 16:28 |
|-----|---|----------|--------------------|----|-----|------------------|